

● PRINTER RUSH ●
(PTO ASSISTANCE)

Application : <u>10/774,515</u>	Examiner : <u>Dolan</u>	GAU : <u>2813</u>
From: <u>DP</u>	Location: <u>IDC</u> FMF FDC	Date: <u>8/18/05</u>
Tracking #: <u>6121698</u>		Week Date: <u>7/4/2005</u>

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[RUSH] MESSAGE: 1449 → pages 12-15 of 24 dated 12-14-2001
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DATE: August 29, 2005
CLIENT NO.: M4065.0697/P697-A, U.S. Patent Application No. 10/774,515
MESSAGE TO: Ms. Rory Burch
COMPANY: U.S. Patent and Trademark Office, Office of Publications
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FROM: James Soo-Chul Derry
PHONE: (202) 777-2598

PAGES (Including Cover Sheet): 5 **HARD COPY TO FOLLOW:** ☐ YES ☒ NO

MESSAGE: U.S. Patent Application No.: 10/774,515

As requested, enclosed are enlarged copies of pages 12-15 of the IDS and Forms-1449 that were submitted to the PTO on February 10, 2004. If you have any additional comments or questions, please contact me at the above-referenced number.

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09/797,635LIST OF ART CITED BY APPLICANT
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John T. Moore et al.FILING DATE
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